



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TECHNOLOGY CENTER 2800

In re application of

Docket No: Q63936

Makoto NONAKA

Appln. No.: 09/823,752

Group Art Unit: 2815

Confirmation No.: 9106

Examiner: George C. ECKERT II

Filed: April 03, 2001

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated May 30, 2002, please amend the above-identified application as follows:

IN THE SPECIFICATION:

The specification is changed as follows:

Please delete the third full paragraph on page 16 and replace it with the following:

The VDD wire 26a has the same structure as that of the VDD wire 16b, and the GND wire 27a has the same structure as that of the VDD wire 17b. A positional relationship between the VDD wire 26a and the GND wire 27a is identical to the positional relationship between the VDD wire 16b and the GND wire 17b.

Please delete the fourth full paragraph on page 16 and replace it with the following:

09/20/2002 JBA/E1 00000006 194800 09823752
01 FC:103 162.00 CH

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